

Appl. No.: 10/814,697
Confirmation No. 7228
Applicant: Xiaolei Shi et al.
Filed: 30 March 2004
Title: NEAR FIELD OPTICAL STORAGE MASK LAYER, DISK, AND FABRICATION METHOD
TC/A.U.: 1795
Examiner: Verderame, Anna L

Docket No.: 140264-1
Customer No.: 6147

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION

In response to the Office action of 29 November 2007, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.